

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Kenichi Kawai

Serial No.:

10/930,150

Conf. No.:

7707

Filed:

August 31, 2004

For:

MAGNETORESISTANCE EFFECT

FILM AND METHOD OF

MANUFACTURING THE SAME

Art Unit:

2622

Examiner:

Ometz, David Louis

I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

4May C

Date

Registration No. 41,895
Attorney for Applicant(s)

AMENDMENT B

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 16, 2007, please amend the above-identified Application as follows: